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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/804,707	03/19/2004	Michael Maschke	P04,0086	7519
7590 SCHIFF HARDIN LLP Patent Department 6600 Sears Tower 233 South Wacker Drive Chicago, IL 60606		11/10/2010	EXAMINER CHAO, ELMER M	
			ART UNIT 3777	PAPER NUMBER
			MAIL DATE 11/10/2010	DELIVERY MODE PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

<b>Examiner-Initiated Interview Summary</b>	<b>Application No.</b> 10/804,707	<b>Applicant(s)</b> MASCHKE, MICHAEL
	<b>Examiner</b> ELMER CHAO	<b>Art Unit</b> 3777

**All Participants:** **Status of Application:** \_\_\_\_\_

(1) ELMER CHAO. (3) \_\_\_\_\_.

(2) Steven H. Noll. (4) \_\_\_\_\_.

**Date of Interview:** 25 October 2010

**Time:** 2:45pm

**Type of Interview:**

- Telephonic
- Video Conference
- Personal (Copy given to:  Applicant     Applicant's representative)

**Exhibit Shown or Demonstrated:**  Yes     No

If Yes, provide a brief description: \_\_\_\_\_.

**Part I.**

Rejection(s) discussed:

Claims discussed:

1, 4

Prior art documents discussed:

**Part II.**

**SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED:**

*Examiner proposed amending the application to include claim 4. Applicants did not agree to at this time.*

**Part III.**

- It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.
- It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.

/Tsc Chen/  
Supervisory Patent Examiner, Art Unit 3777  
/Elmer Chao/  
Examiner, Art Unit 3777

(Applicant/Applicant's Representative Signature – if appropriate)